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**PATENT NUMBER and
ISSUE DATE**

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10064880	08/27/2002	117	13	1765	ANDERSON M

****APPLICANTS:** Lan Chung-Wen;

****CONTINUING DATA VERIFIED:**

note M.H. 9/24/07

**** FOREIGN APPLICATIONS VERIFIED:**

TAIWAN 91103520 02/27/2002

MAA 9/24/03

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PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO	
35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		8819-US-PA	
Verified and Acknowledged Examiners's initials <i>[Signature]</i>			
TITLE : Apparatus for growing stoichiometric lithium niobate and lithium tantalate single crystals and method of growing the same			
U.S. DEPT. OF COMM./PAT. & TM-PTO-436 (Rev. 12-94)			

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED		
			Total Claims	Print Claim for O.G.	
ISSUE FEE		Primary Examiner	DRAWING		
Amount Due	Date Paid		Sheets Drawn	Figs. Drawn	Printed
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Applicant Examiner		
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